



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 3, 2026

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

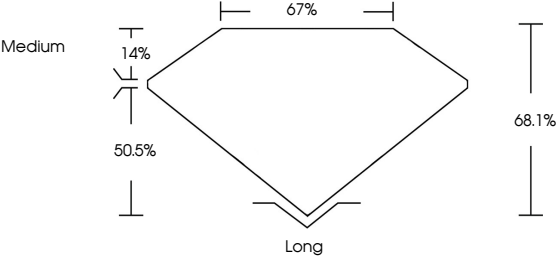
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

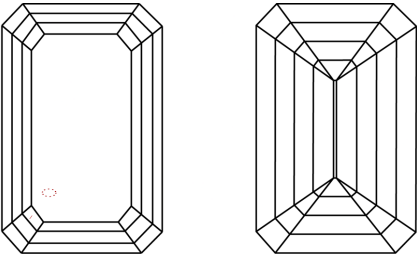
LG818660790

Report verification at [igi.org](#)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

Sample Image Used



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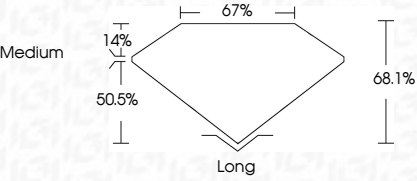
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PROPORTIONS



COLOR

CLARITY

Sample Image Used



LABORATORY GROWN DIAMOND REPORT

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IGI Report No LG818660790

EMERALD CUT

7.88 X 5.52 X 3.76 MM

1.60 CARAT

G

VS 1

EXCELLENT

EXCELLENT

NONE

IGI LG818660790

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IGI



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August 3, 2026

IGI Report No LG818660790

EMERALD CUT

7.88 X 5.52 X 3.76 MM

1.60 CARAT

G

VS 1

68.1%

67%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI LG818660790

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